

PATENT APPLICATION COVER SHEET

COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450



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PATENT TRADEMARK OFFICE

Sir/Madam:

Transmitted herewith is the patent application of:

Inventor(s): George Jonathan Kluth, Joong S. Jeon, Qi Xiang and Huicai Zhong

For: "Method for Forming Polysilicon Gate on High-K Dielectric and Related Structure"

This application is a Continuation Divisional Continuation-in-part (CIP) of prior application
No.: _____.

Enclosed are:

- Three (3) Sheets of drawings
- Request for Non-Publication (Form PTO/SB/35 (11-00))
- An assignment of the invention to Advanced Micro Devices, Inc.
- The enclosed payment includes \$40.00 for the recording of the assignment
- Applicant(s) claim(s) small entity status
- Information Disclosure Statement
- Preliminary Amendment
- Declaration and Power of Attorney
- The filing fee has been calculated as shown below:

(Col. 1)	(Col. 2)	SMALL ENTITY	OTHER THAN A SMALL ENTITY
FOR:	No. Filed	No. Extra	
BASIC FEE		\$385.00	\$770.00
TOTAL CLAIMS	20 -20 =	0	x 18 = \$0.00
INDEPENDENT CLAIMS	3 -3 =	0	x 86 = \$0.00
MULTIPLE DEPENDENT CLAIMS PRESENTED		+145=	+290 = \$
If the difference in Col. 1 is less than zero, enter "0" in Col. 2		TOTAL	TOTAL \$770.00

22388 U.S.P.T.O.
10/678445



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- Enclosed is a payment in the amount of \$810.00 by credit card (Form PTO-2038 attached).
- Please charge Deposit Account No. 50-0731 in the amount of \$ _____.
- The Commissioner is hereby authorized to charge payment of any additional fees associated with this communication, or credit any overpayment to Deposit Account No. 50-0731. A duplicate copy of this sheet is enclosed.

MICHAEL FARJAMI, ESQ.

Date: 10/3/03

Reg. No.: 38,135



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Michael Farjami, Esq.
FARJAMI & FARJAMI LLP
16148 Sand Canyon
Irvine, CA 92618
(949) 784-4600

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I hereby certify that this paper is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 C.F.R. § 1.10 on the date indicated above and is addressed to Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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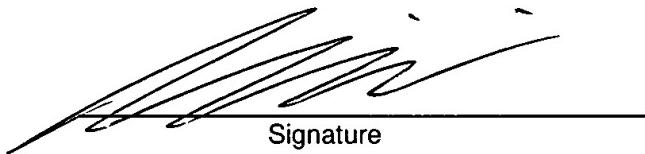
NONPUBLICATION REQUEST UNDER 35 U.S.C. 122(b)(2)(B)(i)	First Named Inventor	Kluth, et al.
	Title	Method for Forming Polysilicon Gate on High-K Dielectric and Related Structure
	Atty Docket Number	0180146

I hereby certify that the invention disclosed in the attached application **has not and will not be** the subject of an application filed in another country, or under a multilateral agreement, that requires publication at eighteen months after filing.

I hereby request that the attached application not be published under 35 U.S.C. 122(b).

10/31/07

Date



Signature

Michael Farjami, Esq.

Typed or printed name

This request must be signed in compliance with 37 CFR 1.33(b) and submitted with the application **upon filing**.

Applicant may rescind this nonpublication request at any time. If applicant rescinds a request that an application not be published under 35 U.S.C. 122(b), the application will be scheduled for publication at eighteen months from the earliest claimed filing date for which a benefit is claimed.

If applicant subsequently files an application directed to the invention disclosed in the attached application in another country, or under a multilateral international agreement, that requires publication of applications eighteen months after filing, the applicant **must** notify the United States Patent and Trademark Office of such filing within forty-five (45) days after the date of the filing of such foreign or international application. **Failure to do so will result in abandonment of this application (35 U.S.C. 122(b)(2)(B)(iii)).**